

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (Not for submission under 37 CFR 1.99)	Application No.	10/568,829
	Filing Date:	February 21, 2006
	First Name Inventor	Siegel et al.
	Art Unit	1796
	Examiner Name	Hui Chin
	Attorney Docket No.	0094.064A

**U.S. PATENTS**

Examiner Initials	Cite No.	U.S. Patent No. or Published Application Number	Kind Code <sup>1</sup>	Issue Date or Publication Date	Name of Patentee or applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear

**U.S. PATENT APPLICATION PUBLICATIONS**

Examiner Initials	Cite No.	Publication Number	Kind Code <sup>1</sup>	Publication Date	Name of Patentee or applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	BA	2002/0070428	A1	2002-06-13	Karl D. EASTHOM	
	BB	2006/0145119	A1	2006-07-06	Hui H. CHIN	

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No.	Foreign Document Number <sup>3</sup>	Country Code <sup>2</sup>	Kind Code <sup>4</sup>	Publication Date	Name of Patentee or applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Figures Appear	Translation	
								Yes	No
	CF	10116702	JP	A	1998-05-06	SANO KIYOHICO et al.		X	
	CG	1 033 724	EP	A1	2000-09-06	CIT ALCATEL et al.		X	
	CH	1188779	CN		07/29/1998	Yu GANG et al.		X	

**NON-PATENT LITERATURE DOCUMENTS**

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	DC	ISA and Written Opinion of the International Searching Authority of International application No. PCT/US2004/027122
	DD	Office Action dated January 7, 2009 from U.S. patent appl. No. 10/531,998
	DE	Office Action dated July 8, 2009 from U.S. patent appl. No. 10/531,998
	DF	Office Action dated December 23, 2009 from U.S. patent appl. No. 10/531,998

EXAMINER: /Hui Chin/

Date Considered

05/19/2010

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP Section 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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